

Form PTO-1449 (R v. 8-88)		U.S. Department of Commerce Patent and Trademark Office		Attorney Docket No. 82822		Serial No. To Be Assigned		
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				Applicant NAKAMURA et al.				
				Filing Date Herewith		Group No.		
U.S. PATENT DOCUMENTS								
Examiner Initial*		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
M	A	JP 08-330316	12/96	Japan	E30B	15/22	✓	
M	B	JP 08-268794	10/96	Japan	C30B	15/20	✓	
M	C	JP 11-157995	06/99	Japan	C30B	22/06	✓	
MS	D	JP 10-152395	06/98	Japan	C30B	22/06	✓	
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)								
	E	Masataka Horai, et al., "Defect Control Technology for Si Crystal Growth (in Japanese)", Transaction of Japan Crystal Growth Society, December 1998, Vol. 25, No. 5, p. 207-213, especially, see p. 211 and Fig. 6.						
Examiner		Date Considered						
Matthew Song		5/2/02						
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